

Notice of References Cited	Application/Control No. 10/538,415		Applicant(s)/Patent Under Reexamination HEER, KLAUS-PETER	
	Examiner JOHN RIVELL		Art Unit 3753	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,007,754 A	02-1977	Beck et al.	137/487.5
*	B	US-4,709,728 A	12-1987	Ying-Chung, Chen	251/129.04
*	C	US-4,896,101 A	01-1990	Cobb, Harold R. W.	73/168
*	D	US-4,948,090 A	08-1990	Chen, Chge-San	251/129.04
*	E	US-5,251,148 A	10-1993	Haines et al.	700/282
*	F	US-5,616,829 A	04-1997	Balaschak et al.	73/46
*	G	US-6,530,277 B2	03-2003	KumpfmueLLer, Hans-Georg	73/168
*	H	US-6,637,267 B2	10-2003	Fiebelkorn et al.	73/592
*	I	US-6,976,503 B2	12-2005	Ens et al.	73/168
*	J	US-7,203,575 B2	04-2007	Maturana et al.	700/282
*	K	US-2008/0053204 A1	03-2008	Neville et al.	73/61.71
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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